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JP 7/23/03 SEC.936

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION of:

Jai Young WOO et al.

Group Art Unit: 2872

Serial No.: 10/071,099

Examiner: Thong Q. NGUYEN

Filed: 11 February 2002

MICROSCOPE FOR INSPECTING
SEMICONDUCTOR WAFER

PROPOSED DRAWING CORRECTIONS

U.S. Patent and Trademark Office
2011 South Clark Place
Customer Window, Mail Stop Non-Fee Amendment
Crystal Plaza Two, Lobby, Room 1B03
Arlington, VA 22202

Sir:

As required by the Examiner on page 2 of the "Office Action" dated 13 February 2003, Applicants submit herewith the attached "Proposed Drawing Corrections."

Specifically, FIG. 7 has been amended to correct the labeling of the reference numerals 241 and 243.

Accordingly, Applicants respectfully request that the Examiner approve these Proposed Drawing Corrections. In the event that there are any outstanding matters remaining in the present application, the Examiner is invited to contact Kenneth D. Springer (Reg. No. 39,843) at (703) 715-0870 to discuss these matters.

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If necessary, the Commissioner is hereby authorized in this, concurrent, and future replies to charge payment or credit any overpayment to Deposit Account No. 50-0238 for any additional fees required under 37 C.F.R. § 1.16 or under 37 C.F.R. § 1.17, particularly extension of time fees.

Respectfully submitted,

VOLENTINE FRANCOS, P.L.L.C.

Date: 14 July 2003

By: _____


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